Application Number:	10659213					
Filing Date:	10-Sep-2003					
Title of Invention:	Substrate processing apparatus					
First Named Inventor/Applicant Name:	Katsuhiko Miya					
Filer:	Douglas Alan Miro					
Attorney Docket Number:	P/1250-261					
Filed as Large Entity	•			0		
Utility Filing Fees		_ ~ ~ ,			16.7	
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)	
Basic Filing:			1.			
Pages:						
Claims:						
Miscellaneous-Filing:						
Petition:						
Patent-Appeals-and-Interference:						
Post-Allowance-and-Post-Issuance:						
Extension-of-Time:						

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	810	810
	Tota	1270		